

Applicant(s): T. KAWANO

Serial No. : 09/840,193

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: April 23, 2001

For

: RADIATION IMAGE PROCESSING

APPARATUS

Art Unit Examiner

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

SIR:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the date noted below.

Attorney: Leonard Holt

Dated: August 21, 2001

In the event that this Paper is late filed, and the necessary petition for extension of time is not filed concurrently herewith, please consider this as a Petition for the requisite extension of time, and to the extent not tendered by check attached hereto, authorization to charge the extension fee, or any other fee required in connection with this Paper, to Account No. 06-1378.

Submitted herewith is a copy of each of the Japanese publications (including English language Abstracts) mentioned in the specification, together with a PTO/SB/08A form listing the particulars thereof.

It is respectfully requested that the Examiner consider the publications submitted herewith and make them of record. further requested that the Examiner return an initialed copy of the attached form PTO/SB/08A to confirm that the publications listed therein have been made of record.

Respectfully submitted,

Leonard Holtz, Esq. Req. No. 22,974

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U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE									
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1 1 724 307			ttorne	y Docket Number 01246/LH					
U.S. PATENT DOCUMENTS									
Exam. Cite Inits* No ¹		Document Number		Kind Code ²	Name of Patentee o Applicant	or	Publication Date MM-DD-YYYY	Relevant Portion	
FOREIGN PATENT DOCUMENTS									
Exam Inits*	Cite No ¹	Offc³	Document Number4	Kind Code⁵	Name of Patentee o Applicant		Publication Date MM-DD-YYYY	Relevant Portion	Т6
	1	JP	55-012429*		MATSUMOTO, ET AL		01-29-1980		
'		JP	63-189853*		TSUCHINO, ET AL		08-05-1988		
	J	JP	06-304159*		H. TAKEO		11-01-1994		
		JP JP JP JP	06-304160* 06-342098* 09-090048* 11-085950* 11-096380* * (INCLUDING ENGLISH LANGUAGE ABSTRACTS)		H. TAKEO LEE, ET AL MOCHIZUKI, ET AL H. ARAHATA H. ARAHATA		11-01-1994 12-13-1994 04-04-1997 03-30-1999 04-09-1999		
Examiner					Date				

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Considered

DATE MAILED: August 21, 2001

Signature

¹ Unique citation designation number. ² See kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Place a check here if English translation is attached.